

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of

REDEKER et al.

Application No.: 10/734,704

Filed: December 12, 2003

For: METHOD AND APPARATUS FOR
SEMICONDUCTOR WAFER
PLANARIZATION




Examiner: Edwards, Laura Estelle

Art Unit: 1734

Docket No.: LAM2P461

Date: July 24, 2006

☐ DuplicateCERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on July 24, 2006.
Signed: 

Kenneth D. Wright

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

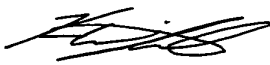
Sir:

Transmitted herewith is a Request for Reconsideration in the above-identified application.
The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	16 -	20	0	X25 = \$	OR	X50 = \$
INDEP CLAIMS	3 -	3	0	X100 = \$	OR	X200 = \$
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180		\$360
TOTAL				\$		\$

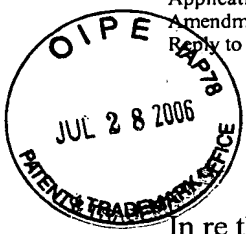
- ☒ Applicant believes that no Extension of Time is required; however, if it is determined that such an extension is required, Applicant hereby petitions that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM2P461).
- ☒ If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P461). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP


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TFO AF



Application No. 10/734,704
Amendment Dated July 24, 2006
Reply to Final Office Action of May 23, 2006

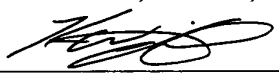
PATENT

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REDEKER et al.) Examiner: Edwards, Laura Estelle
Application No.: 10/734,704) Art Unit: 1734
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Signed: 
Kenneth D. Wright

REQUEST FOR RECONSIDERATION

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Request for Reconsideration is submitted in response to the Final Office Action dated May 23, 2006, and within the two month period extending from the date of the Final Office Action to July 24, 2006. Please note that July 23, 2006, is a Sunday. Therefore, the two month after-final period extends to Monday, July 24, 2006. Please enter the following remarks.

The Claims are reflected in the listing of claims which begins on page 2 of this Request for Reconsideration.

Remarks/Arguments begin on page 7 of this Request for Reconsideration.